

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:	Docket No.:	UTP-182US
Meng Tao, et al.	Art Unit:	1794
Serial No: 10/822,343	Examiner:	Speer, Timothy M.
Filed: April 12, 2004	Conf. No.:	3111
For:	SUPPRESSION OF CHEMICAL REACTIVITY ON SEMICONDUCTOR SURFACES	

**RESPONSE TO FINAL OFFICE ACTION MAILED AUGUST 1, 2008**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Examiner's Final Office Action mailed August 1, 2008, please amend this application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.